



Reg. Number	17033 A - I	Valid From	2020-12-10
First issue date	2009-10-19	Last change date	2020-12-10
Valid until	2021-10-18	Sector IAF	17

Occupational Health and Safety Management System Certificate **ISO 45001:2018**

We certify that the Occupational Health and Safety Management System of the Organization:

CO.ME.AR. S.r.l.

Is in compliance with the standard UNI ISO 45001:2018 for the following products/services:

Mechanical precision machining for industrial and aeronautical components using CNC systems

Chief Operating Officer
Giampiero Belcredi

The maintaining of the certification is subject to annual surveillance and dependent on the observance Kiwa Cermet Italia contractual requirements.

This certificate is composed by 1 page.

This certificate is in support of the certificate number 17033 GROUP and subject to its validity.

The date of first issue refers to the certification with registration number 1524 previously issued to the same Organization.

CO.ME.AR. S.r.l.

Registered Headquarters

- Viale della Tecnica snc Zona Industriale 06038 Spello (PG) Italy

Certified sites

- Viale della Tecnica snc Zona Industriale 06038 Spello (PG) Italy

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SGQ N° 007A	SSI N° 006G	PRS N° 089C
SGA N° 010D	FSM N° 004I	ISP N° 113E
PRD N° 069B	SCR N° 013F	LAB N° 0001
EMAS N° 012P	SGE N° 004M	LAT N° 052

Membro di MLA EA per gli schemi di accreditamento SGQ, SGA, PRD, PRS, ISP, GHG, LAB, LAT e PTP di MLA IAF per gli schemi di accreditamento SGQ, SGA, SSI, FSM, PRD e PRS e di MRA ILAC per lo schema di accreditamento LAB, MED, LAT e ISP

Signatory of EA MLA for the accreditation schemes QMS, EMS, PRD, PRS, INSP, GHG, TL, CL and PTP of IAF MLA for the accreditation schemes QMS, EMS, ISMS, FSMS, PRD and PRS, and of ILAC MRA for the accreditation scheme TL, ML, CL and INSP